

Application/Control No.	Applicant(s)/Patent under Reexamination
09/848,773	CHEN ET AL.
Examiner	Art Unit

Examiner Art Unit

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SEARCHED					
Class	Subclass	Date	Examiner		
345	419	1/23/2006	KN		
345	420	1/23/2006	KN		
345	421	1/23/2006	KN		
345	423	1/23/2006	KN		
345	424	1/23/2006	KN		
345	427	1/23/2006	KN		
382	154	1/23/2006	KN		
382	226	1/23/2006	KN		
382	294	1/23/2006	KN		

INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
345	424	1/23/2006	KN	
345	423	1/23/2006	KN	
345	427	1/23/2006	KN	
38	32	1/23/2006	KN	

SEARCH NO (INCLUDING SEARCI)
	DATE	EXMR
EAST: classification	1/23/2006	KN
WEST: text search	1/23/2006	KN
NPL: ACM, IEEE	1/23/2006	KN